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CONFIRMATION NO. 4981

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/530,475	04/06/2005 RULE	438	2813	050179		
APPLICANTS Masahide Kawaraya, Hiratsuka-shi, JAPAN; Iwao Hayashi, Hiratsuka-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/13019 10/10/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-297385 10/10/2002 JAPAN 2003075849 03/19/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /COLLEEN E RODGERS/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 0	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 1
ADDRESS KRATZ, QUINTOS & HANSON, LLP 1420 K Street, N.W. Suite 400 WASHINGTON, DC 20005 UNITED STATES						
TITLE Method for forming semiconductor film and use of semiconductor film						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			